

Notice of References Cited	Application/Control No. 10/656,840	Applicant(s)/Patent Under Reexamination MOFFATT ET AL.	
	Examiner Kelly Stouffer	Art Unit 1762	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bunshah et al. "Deposition Technologies for Films and Coatings: Developments and Applications" 1982, Noyes Publications, Park Ridge, NJ, p339
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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